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### Contents

**1-8 Lowering the density of dislocations in heteroepitaxial III-nitride layers: Effect of sapphire substrate treatment (review)** *P.V. Parphenyuk, A.A. Evtukh* 

**9-13** Electron transport through nanocomposite SiO<sub>2</sub>(Si) films containing Si nanocrystals O.L. Bratus, A.A. Evtukh, O.V. Steblova, V.M. Prokopchuk

14-22 Physical mechanisms and models of the long-term transformations in radiative recombination observed in *n*-GaAs under microwave irradiation

G.V. Milenin, R.A. Redko

23-27 Automated method for determining the etch pits density on crystallographic planes of large semiconductor crystals

G.S. Pekar, A.A. Singaevsky, A.F. Singaevsky

28-33 Search of mode wavelengths in planar waveguides by using the wave equation Fourier transform method

V.M. Fitio, V.V. Romakh, Ya.V. Bobitski

**34-38** Acoustic-stimulated relaxation of GaAs<sub>1-x</sub>P<sub>x</sub> LEDs electroluminescence intensity

O.V. Konoreva, M.V. Lytovchenko, Ye.V. Malyi, Ya.M. Olikh, I.V. Petrenko, M.B. Pinkovska, V.P. Tartachnyk

**39-43** Features of tensoresistance in single crystals of germanium and silicon with different dopants *P.I. Baranskii, G.P. Gaidar* 

# 44-46 Temperature effect on light polarization in uniaxial crystals

M.R. Kulish, V.M. Litvinova, M.I. Malysh, I.O. Sokolovskyi

**47-51 Speckle pattern formation in spatially limited optical systems** *M.M. Kotov, V.N. Kurashov, A.A. Goloborodko* 

52-56 Increasing the specularity of surface scattering of conduction electrons caused by adsorption of a hydrogen monolayer on the W(110) surface

S.V. Sologub, I.V. Bordenyuk, O.V. Kanash, R.H. Amirov

## 57-61 Optical properties of graphene film growing on a thin copper layer

T.S. Rozouvan, L.V. Poperenko, V.G. Kravets, I.A. Shaykevich

### 62-66 Peculiarities of photoluminescence spectra behavior in SiC crystals and films during phase transformations

S.I. Vlaskina, G.N. Mishinova, V.I. Vlaskin, V.E. Rodionov, G.S. Svechnikov

### 67-74 Analysis of the silicon solar cells efficiency. Type of doping and level optimization

A.V. Sachenko, V.P. Kostylyov, M.V. Gerasymenko, R.M. Korkishko, M.R. Kulish, M.I. Slipchenko, I.O. Sokolovskyi, V.V. Chernenko

**75-78 Thermally stimulated conductivity in InGaAs/GaAs quantum wire heterostructures** *S.A. Iliash, S.V. Kondratenko, A.S. Yakovliev, Vas.P. Kunets, Yu.I. Mazur, G.J. Salamo* 

# 79-83 Electrical and optical parameters of Cu<sub>6</sub>PS<sub>5</sub>I-based thin films deposited using magnetron sputtering

I.P. Studenyak, A.V. Bendak, V.Yu. Izai, P.P. Guranich, P. Kúš, M. Mikula, B. Grančič, M. Zahoran, J. Greguš, A. Vincze, T. Roch, T. Plecenik

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84-89 Optimization of surface plasmon resonance based biosensor for clinical diagnosis of the Epstein–Barr herpes virus disease *R.V. Khrystosenko* 

90-97 Microanalysis of magnetic structure of yttrium-iron garnet films by scanning probe microscopy methods

O.I. Synhaivska, P.M. Lytvyn, I.P. Yaremiy, A.O. Kotsyubynsky, V.V. Kozub, V.S. Solnstev, I.V. Prokopenko

**98-108 Electronic structure of 2H-SnSe<sub>2</sub>:** *ab initio* **modeling and comparison with experiment** *D.I. Bletskan, K.E. Glukhov, V.V. Frolova* 

109-115 Carbon ceramics from plants: Graphitization of biomorphic matrixes

D.A. Iarmolenko, A.E. Belyaev, V.S.Kiselov

**116-123** The charge trapping/emission processes in silicon nanocrystalline nonvolatile memory assisted by electric field and elevated temperatures *V.A. Ievtukh, V.V. Ulyanov, A.N. Nazarov* 

**124** Information for contributors

125-126 Contents

127 Publication Ethics and Publication Malpractice Statement